

Notice of References Cited	Application/Control No. 10/661,194	Applicant(s)/Patent Under Reexamination CAHILL ET AL.	
	Examiner Edna Wong	Art Unit 1753	Page 1 of 1

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*	B	US-5,076,813	12-1991	Alberici et al.	44/300
*	C	US-5,326,440	07-1994	Pasternak et al.	204/157.15
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	U	BES OPTICS INC., "Schott Optical Filters" (no date), pp. 1-4.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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